



INTERNATIONAL  
GEMOLOGICAL  
INSTITUTE

ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

September 19, 2024

IGI Report Number  
LG634493856

Description  
LABORATORY GROWN DIAMOND

Shape and Cutting Style  
OVAL BRILLIANT

Measurements  
9.50 X 6.26 X 3.88 MM

GRADING RESULTS

Carat Weight  
1.43 CARAT

Color Grade  
D

Clarity Grade  
VS 1

ADDITIONAL GRADING INFORMATION

Polish  
EXCELLENT

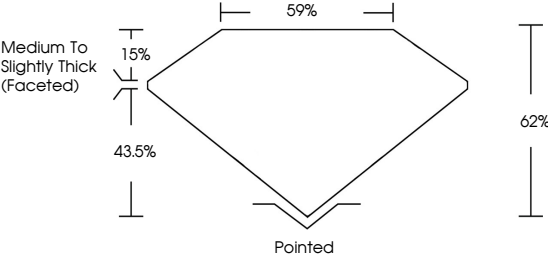
Symmetry  
EXCELLENT

Fluorescence  
NONE

Inscription(s)  
IGI LG634493856

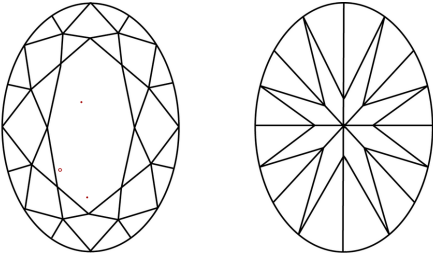
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.  
Type IIa

PROPORTIONS



Medium To Slightly Thick (Faceted)

CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.  
Green symbols indicate external characteristics.

COLOR

D E F G H I J Faint Very Light Light

CLARITY

IF VVS 1-2 VS 1-2 SI 1-2 I 1-3

Internally Flawless Very Very Slightly Included Very Slightly Included Slightly Included Included



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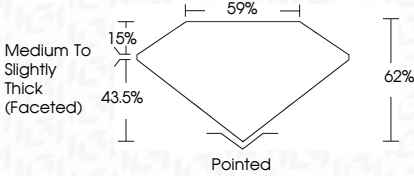
Polish  
EXCELLENT

Symmetry  
EXCELLENT

Fluorescence  
NONE

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OVAL BRILLIANT

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Carat Weight  
1.43 CARAT

Color Grade  
D

Clarity Grade  
VS 1

Depth  
62%

Girdle  
59%

Medium to Slightly Thick (Faceted)

Pointed

Culet  
EXCELLENT

Polish  
EXCELLENT

Symmetry  
EXCELLENT

Fluorescence  
NONE

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